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FIG. 1A

FIG. 1B

103

104

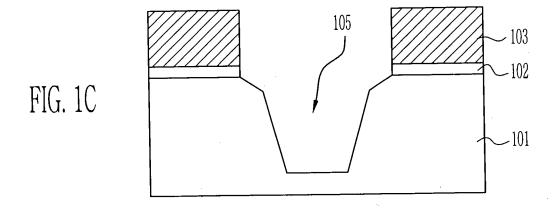
103

103

104

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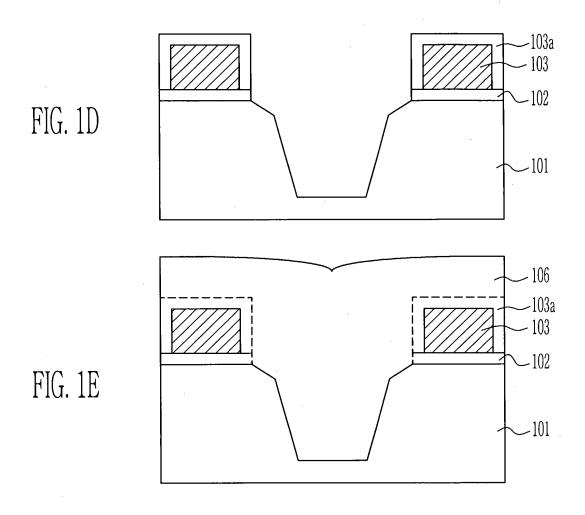
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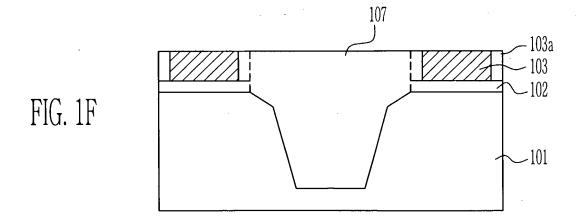


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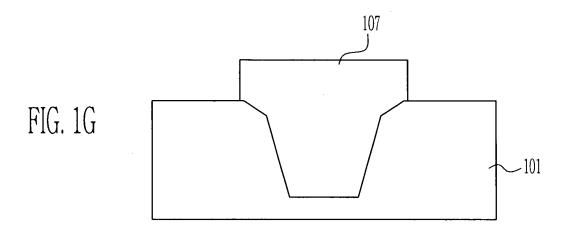
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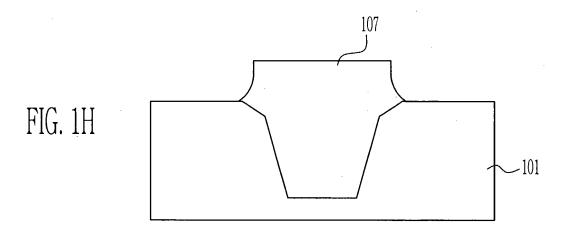




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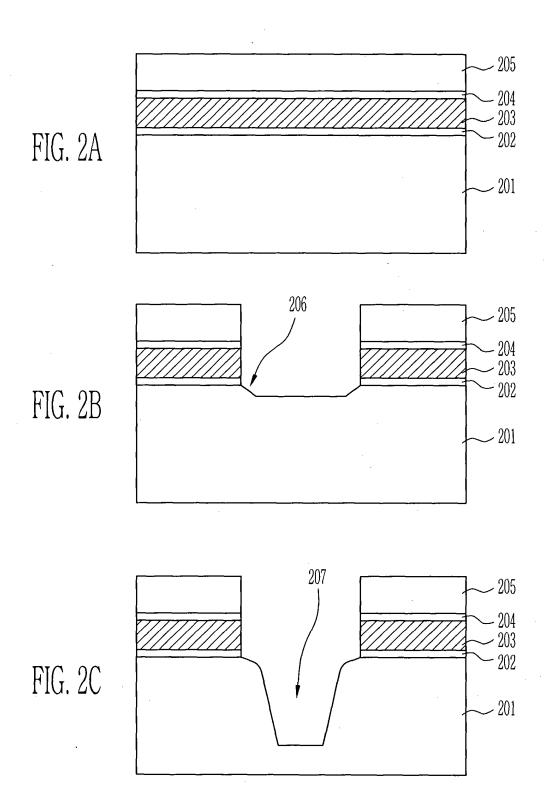




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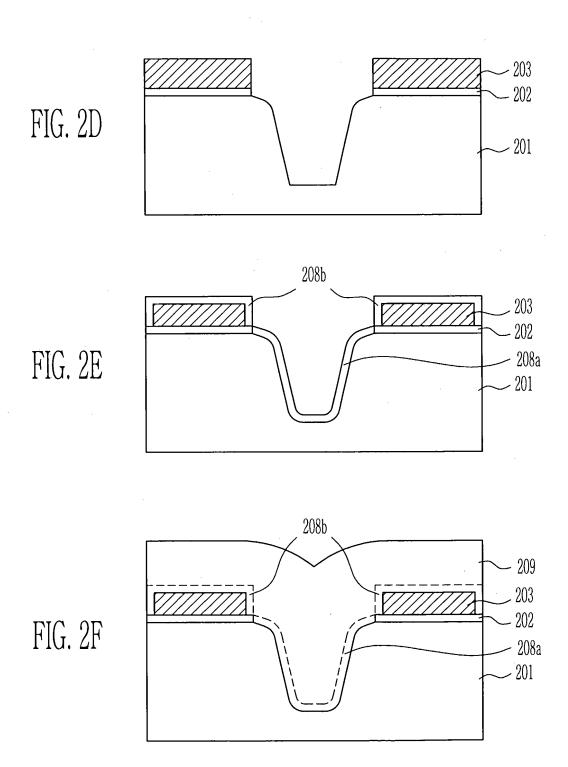
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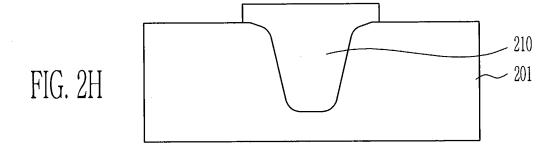


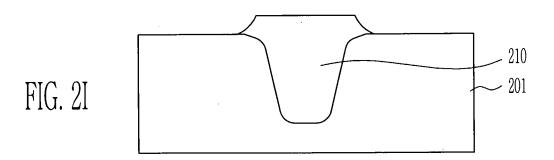
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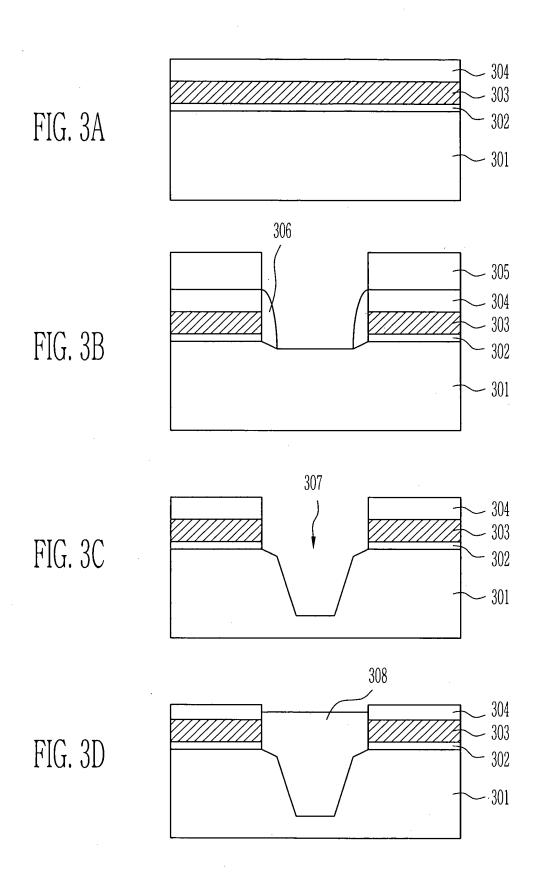
FIG. 2G 203





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